

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re the Application of: **Tomoharu NAKANO et al.**

Group Art Unit: **Not yet assigned**

Application Number: **10/552,606**

Examiner: **Not yet assigned**

Filed: **October 5, 2005**

Confirmation Number: **6380**

For: **POLISHING LIQUID FOR CMP PROCESS AND POLISHING  
METHOD**

Attorney Docket Number: **052463**

Customer Number: **38834**

**PETITION FOR EXTENSION OF TIME**

Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

April 6, 2007

Sir:

Applicants petition the Commissioner for Patents to extend the time for response to the Notification of Missing Requirements dated January 17, 2007 for one month from March 17 to April 17.

Attached please find a check in the amount of \$120.00 for the cost of the extension. If any additional fees are due in connection with this paper, please charge Deposit Account No. 50-2866.

Respectfully submitted,

**WESTERMAN, HATTORI, DANIELS & ADRIAN, LLP**

  
Shuji Yoshizaki

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